Narrow-band EUV multilayer coating for the MOSES sounding rocket

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ABSTRACT

The *Multi-order Solar EUV Spectrograph (MOSES)* is a slitless spectrograph designed to study solar He II emission at 303.8 Å (1 Å = 0.1 nm), to be launched on a sounding rocket payload. One difference between MOSES and other slitless spectrographs is that the images are recorded simultaneously at three spectral orders, m = -1, 0, +1. Another is the addition of a narrow-band multilayer coating on both the grating and the fold flat, which will reject out-of-band lines that normally contaminate the image of a slitless instrument. The primary metrics for the coating were high peak reflectivity and suppression of Fe XV and XVI emission lines at 284 Å and 335 Å, respectively. We chose B_4C/Mg_2Si for our material combination since it provides excellent peak reflectivity and rejection of out-of-band wavelengths. Measurements of witness flats at NIST indicate the peak reflectivity at 303.8 is 39.0% for a 15 bilayer stack, while suppression ranges from 7.5x to 12.9x at 284 Å and from 3.4x to 15.1x at 335 Å for the individual reflections in the optical path. We present the results of coating the MOSES flight gratings and fold flat, including the spectral response of the fold flat and grating as measured at NIST's SURF III and Brookhaven's X24C beamline, respectively.

Keywords: EUV multilayers, narrow band multilayers, B₄C/Mg₂Si

1. INTRODUCTION

The solar atmosphere presents a tremendous challenge for remote sensing observations. Coronal mass ejections, flares, microflares, and other dynamic phenomena show variability at small temporal and spatial scales. The solar observer is often left with an uncomfortable compromise between spectral, spatial and temporal resolution. The desire to combine imaging and spectroscopic capabilities has produced a variety of compromises. In visible light, for example, tunable Fabry-Perot interferometers have made it possible to image slices of a spectral line profile in rapid succession. In extreme ultraviolet (EUV), the options are limited because there are no materials with high transmission coefficients. Yet this spectral range is of considerable importance to solar physics because it gives access to the sun's dynamic corona and transition region. The NRL SO82A experiment aboard Skylab¹ used an objective grating to produce overlapping, dispersed images in a multitude of solar EUV spectral lines. The *Multi-Order Solar EUV Spectrograph* (*MOSES*) represents a new approach: truly simultaneous imaging and spectroscopy by recording images at several spectral orders of a narrowband objective grating (see Figure 3). Each of the images obtained by *MOSES* is equivalent to a projection through the three-dimensional hybrid space (x, y, λ) occupied by the object. The central (m = 0) order is a simple image.² The two dispersed orders, like the images from SO82A, are difficult to interpret by themselves. By inversion or forward modeling, we may solve for spectra consistent with the measurements in all three spectral orders at

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each image pixel.³ Since multilayer coatings are used on the optics, the instrument bandpass is limited to two spectral lines: He II 303.8Å and Si XI 303.3Å (1 Å = 0.1 nm). Simultaneous imaging at three spectral orders, combined with a narrow bandpass, makes the spectral inversion feasible. The MOSES sounding rocket mission is a proof-of-concept for this novel technique.

In this paper, we describe the fabrication and test of multilayer coatings for the MOSES grating and fold flat. We chose B₄C/ Mg₂Si as the material combination due to its very high reflectivity at the target wavelength, and excellent suppression of nearby emission lines which could contaminate the image. Coating tests and flight optics coatings were done in the Optics Branch at Goddard Space Flight Center. Measurements of test and witness samples for the fold flat coatings were done at SURF III at the National Institute of Standards and Technology, and flight grating performance measurements were done at beam line X24C of the National Synchrotron Light Source at Brookhaven National Laboratory. Coatings optimized to peak at 303.6 Å yield nearly 40% reflectivity and a relatively narrow 20.5 Å FWHM.

2. DEPOSITION FACILITIES

Initial deposition tests were done in a small Commonwealth ion beam sputtering deposition chamber.* The sputter source is a 3 cm ion gun, operating at 1000 V and 30 mA. The base pressure of the chamber is 3×10^{-7} Torr, and the operating pressure is 4×10^{-4} Torr. This chamber has a computer controlled 4-target turret, with 3" diameter target capacity. The B_4C and Mg_2Si targets are 99.9% and 99.5% purity, respectively. Sample substrates are 50 mm square by 2 mm thick float glass, which undergo a standard aqueous cleaning process used for all test samples in our laboratory. Deposition was monitored by a Leybold quartz crystal microbalance, and controlled by software developed in-house. Samples were analyzed using grazing incidence x-ray reflectivity (GIXR) and near-normal incidence EUV reflectivity. Once the optimum recipe for the multilayer stack was verified using this small chamber, further development was moved to our 2-meter diameter chamber where the flight optics were coated.

The 2-meter chamber has been described previously,⁴ but in brief, houses two 16 cm ion beam sources directed at two fixed 30 cm diameter targets. Substrates are held in a rack that rotates about the center of the chamber from one sputter source to the other, and back. No other rotation stages or baffles were used during this development to enhance uniformity beyond the inherent sputtering profile, though we are in the process of testing a new rotation system now. The lateral uniformity of coating thickness was determined by GIXR measurements to be 0.055% per mm over the central 90 mm radius tested. The implications of this non-uniformity are shown in later in Section 4, Coating Design.

3. METROLOGY

Measurement of test coatings was primarily done at GSFC using a combination of grazing incidence x-ray reflectivity (GIXR) at 8.048 keV and direct EUV measurements. The GIXR instrument consists of an Oxford Apogee Cu target x-ray tube, a Si(220) 4-bounce channel-cut monochromator, and a 0.065 mm x 4 mm slit to filter and collimate the Cu $K\alpha_1$ x-ray line. When operated at 45 kV and 0.8 mA, this system yields 20,000 sec⁻¹ in the direct beam. Samples are mounted on a pair of stacked Newport 495 rotation stages, and a Newport 850G-driven translation stage to move the sample in and out of the beam. A xenon proportional counter with a 0.2 mm x 10 mm slit is used to detect the x-rays, with a background count rate of 0.1 c/sec.

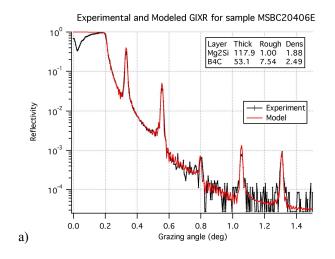
Normal incidence EUV measurements are performed on a McPherson 247 spectrometer. A Penning EUV light source from Berkeley Photonics⁵ is mounted on the scanning slit port, and a 600 mm⁻¹ gold-coated, grazing incidence reflection grating and 0.1 mm exit slit are used to pick off emission lines from the light source. In our region of interest the only lines used are from Ne II and Ne III emission. The top and bottom flanges of the sample vacuum chamber are custom rotary seals operated by hand, and have vernier graduated scales with read-out to 0.1 degree. The sample is held in a mount on the top flange that can move in and out of the beam, with a micrometer stop to repeatably position the sample

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^{*} Commercial products are mentioned only for clarity; mention of a product does not constitute endorsement by the authors or the US Government.

in the beam. The detector is an Amptek MD-502 channel electron multiplier operating in ion mode mounted on the bottom flange, with the 3.8 mm diameter detector aperture located 50 mm from the sample.



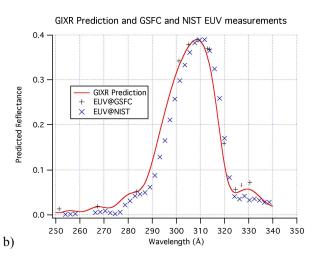


Figure 1 a) Grazing incidence x-ray reflectivity of a test mirror during the coating development process. b) Prediction and measurement of the EUV response at 5 degrees incident angle.

Using GIXR measurements, structural models of test coatings are generated, from which the EUV performance is predicted. These predictions are compared to direct EUV measurements using a gas discharge EUV light source mounted to the scanning slit of a 2.2 meter diameter McPherson reflection grating spectrometer. The absolute reflectivity obtained using this EUV reflectometer system has not been well established, so only the bandpass position information was used from these EUV measurements. Absolute EUV reflectivity measurements on important samples were performed at the NIST/DARPA EUV Reflectometry facility at NIST. This is a high-throughput, modest resolution instrument based on varied-line-spacing plane gratings. Uncertainties in the reflectivity values reported here are 10% of the peak value, while uncertainties in the peak wavelength are 1 Å.

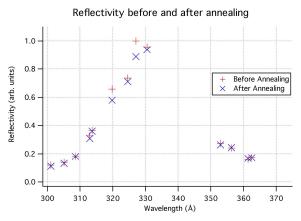


Figure 2. Annealing study of a test coating on a standard float glass slide. The sample was annealed at 100° C for 6 hours in ambient atmosphere.

The structural models based on GIXR measurements are found to be accurate within approximately 2 Å, based on comparing bandpass position predictions with NIST measurements. Peak reflectivity predictions cannot be done rigorously at this time, since the optical constants of Mg₂Si are not yet well known in the 300 Å region. An example of this prediction and comparison process is shown in Figure 1.

In Figure 1a), the coating is a 15 bilayer stack of B₄C/Mg₂Si. The model that is built and fit to the data in a) is used to predict the EUV performance by simulating the model's performance using Windt's IMD package. A comparison of that predicted performance and the actual NIST measurement is shown in b). Measurements from the EUV spectrometer at GSFC are also shown for reference. The prediction curve from the IMD simulation and GSFC EUV measurements are scaled to the peak reflectivity of the NIST absolute reflectivity measurement.

The process of tuning our deposition parameters depends critically on the use of both GIXR and normal incidence EUV reflectivity. Using just the EUV response measurements we know whether the bilayer thickness needs to be tuned up or down to place the peak at the desired position, but we do not know which layer in the period to change to maintain an optimal ratio of layer thicknesses. The most important characteristic of GIXR is that it gives us a measure of the individual thickness of the layers in a bilayer, allowing us to fully optimize the coating.

All samples passed standard tape pull tests, and showed little change upon annealing at 100° C for 6 hours, as shown in Figure 2.

4. COATING DESIGN

Material considerations

One of the primary specifications of the MOSES coatings is the rejection of out of band signal. Specifically, the Fe XV and XVI lines at 284 Å and 335 Å need to be suppressed as much as possible. The other primary requirement is high reflectance at 303.8 Å, but suppression is considered a more important factor, since the instrument is signal-to-noise limited as opposed to photon limited.

A number of candidate material combinations were considered, including Si/Ir, Si/Mo, Si/B_4C and a variety of materials using Mg_2Si as the spacer layer. Previous experimental work⁸ indicated that Mg_2Si may be a superior spacer layer to silicon, in that it is slightly less absorptive than silicon, and since it is also a stable compound it is less likely to produce undesirable silicides at layer interfaces. Following preliminary results from development of the SECCHI EUVI instrument, we chose to pursue further development of the B_4C/Mg_2Si system, which showed high reflectivity and narrow bandpass.

Initial tests were done with 15 and 30 bilayer coatings, but simulations showed that the reflectivity of a 15 bilayer stack peaked only 1% lower than that of a 30 bilayer stack, and the FWHM of the bandpass did not appreciably change. Also, we were also concerned with the lifetime of the filaments in our ion guns, and chose to limit the risk of a filament burning out during deposition of the flight optics by proceeding with 15 bilayer coatings for both test samples and flight optics.

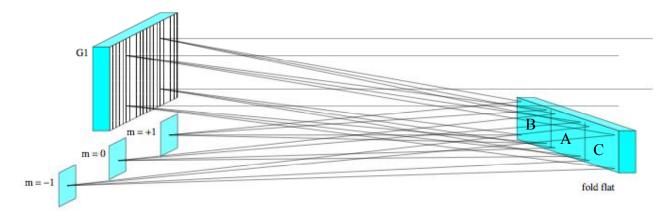
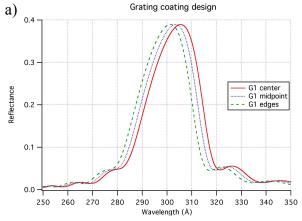
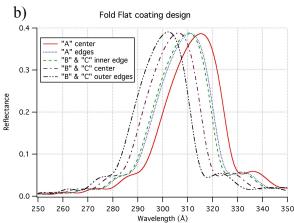


Figure 3. Schematic of the optical layout of *MOSES*. The spherical G1 grating reflects and disperses light onto the three sections of the fold flat, A, B and C, which reflects light into three imaging CCD detectors, corresponding to the three orders, m = 0, +1 and -1 respectively.

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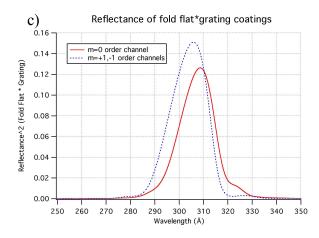


Figure 4. Grating and Fold Flat coating designs. a) EUV response of the designed coating at the center, halfway to the edges (midpoint), and at the edges of the grating. b) EUV response of the fold flat coating at a variety of positions. c) The combined EUV response of the grating and fold flat (coating only) at the center of each section.

Substrates

The grating is a 90 mm square, 16 mm thick blank, with a centered, ruled area of 80 mm square. The surface has a spherical curvature, with a radius of curvature of 9474 mm, and the groove frequency is 950 mm⁻¹. The fold flat is a rectangular mirror 193 mm wide by 50.8 mm tall by 25.4 mm thick, superpolished to a surface roughness of 5 Å RMS or better. The EUV reflecting surface of the fold flat was masked during coating to yield three equally sized sections, each 60 mm by 45 mm. A schematic of the optical layout of *MOSES* is shown in Figure 3.

As can be seen in Figure 1b the general shape of the reflectance curve falls more sharply on the long wavelength side, compared to the short wavelength side. Since the Fe XV 284 Å line is so much closer to the center of our desired bandpass, the peak of the reflectivity curve was deliberately shifted to slightly longer wavelength in our design to optimize the balance between throughput at 303.8 Å and suppression at 284 Å. In addition, we also needed to address the non-uniformity of the coating, especially across the surface of the fold flat.

Non-uniformity issues

As MOSES is the first multilayer program our 2-meter diameter chamber was used for, we did not have opportunity to institute rotation stages or baffling in the substrate mount to improve coating uniformity beyond the inherent distribution of the sputtering sources. As a result, very careful alignment of the substrate rack with respect to the sputter sources was required. This also meant that the d-spacing of the multilayer varies across the surface of the grating and fold flat. Even from the center of the grating to its edge, the d-spacing changes on the order of 2.5 Å, yielding a shift in the peak position of 4.1 Å. The change over the length of the fold flat is more dramatic, with a center-to-edge peak shift of 13.1 Å.

The variation in coating thickness along the surface leads to a choice of how to design the bandpass for optimal performance. Since the m=0 reflection from the grating will be stronger than the m=+1 or -1 reflections, we can afford to design the m=+1 and -1 sections of the fold flat (sections B and C, respectively) to have approximately the same multilayer parameters as the grating. The m=0 section of the fold flat (section A) is then shifted to longer wavelength, but the combined m=0 channel still has a higher reflectivity than the m=+1 and -1 order channels when the grating efficiency is taken into account. The designed bandpasses for the individual grating and fold flat, and the combined throughput are shown in Figure 4. Since we did not have an estimate of the groove efficiency

of the grating at the time the design was done, only the effects of the multilayer coating are included in this analysis.

The combined reflectance from all combinations of positions was considered when optimizing the coating design. Since the Fe XVI line (335 Å) is further away in wavelength from He II (303.8 Å) than the Fe XV line (284 Å) we deliberately chose to bias our design toward longer wavelength. This has the benefit of balancing out the rejection of the two Fe lines and providing some insurance against any slight downward drifts in thickness during the flight mirror deposition run. The final design parameters are shown in Table 1. The values of d-spacing, peak position and suppression of the two Fe lines are given for the center of each optical surface.

Material combination	B ₄ C/Mg ₂ Si		
# of bilayers	15		
d-spacing	G1 = 162 Å		
	FF-A = 168 Å		
	FF-B/C = 163 Å		
Gamma ratio	0.3		
Peak position	G1 = 305.5 Å		
	FF-A = 315.3 Å		
	FF-B/C = 306.3 Å		
Combined	m = 0 to 284 Å = 39.7x		
suppression	m = 0 to 335 Å = 76.9x		
	m = +1 and -1 to 284 Å = 36.8x		
	m = +1 and -1 to 335 Å = 240.8x		

Table 1. Multilayer coating design parameters. G1 is the grating, FF-A is the central section of the fold flat (section A), and FF-B/C are the centers of the outer sections of the fold flat that reflect the m = +1 and -1 orders from the grating (sections B and C).

The suppression values given in Table 1 correspond to the ratio of the reflectivity of the grating times the fold flat at 303.6 Å to that at 284 Å and 335 Å respectively. While the 240.8x suppression of the 335 Å in the m = +1 and -1 order channels seems unrealistically high, it is borne out in measurements of the flight coating performance.

5. PERFORMANCE

The EUV performance of the coated grating, G1, was measured at beamline X24C of the National Synchrotron Light Source at Brookhaven National Laboratory. The large vacuum chamber, designed for calibration of optical components and complete spaceflight and laboratory instruments, can accommodate a mirror or grating of up to 250 mm x 250 mm in size. The dual-element monochromator, comprising a gold coated mirror and a 600 mm⁻¹ grating, provides 2.8 nm to 110 nm EUV wavelengths with spectral resolution of approximately 400. A Mg filter was used to suppress higher harmonic radiation and the Mg L edge was used to calibrate the wavelength scale. The spectral response was measured at the center of the grating, yielding a peak reflectivity of 15.4% at 305.3 Å, corresponding well with our designed peak at 305.5 Å. Assuming the grating coating performs as other coatings on witness samples, we estimate the groove efficiency to be 39.6%. Diffraction scans at 305.3 Å were measured at a variety of positions across the surface, and show $\pm 7.8\%$ uniformity across m = 0 order peaks and proper balance between the strength of the m = +1 and -1 orders, as shown in Figure 5. The m = +1 order peak is on average 47.2% of the m = 0 order peak, while the m = -1 order peak is 46.7% of the m = 0 order. The spectral response is shown later in Figure 7 along with that of the fold flat.

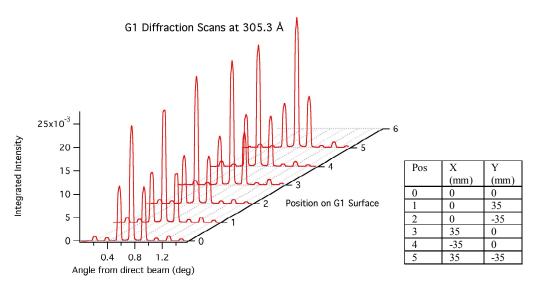


Figure 5. Diffraction scans at a variety of positions across the surface of G1. Positions indicated in the table are with respect to the center of the grating.

In order to minimize the exposure of the coated fold flat and the difficulty in handling a relatively large optic, only witness samples were measured to gauge its coated performance. For the deposition run immediately previous to coating the fold flat, six witness slides were mounted, with three placed at the center of each of the fold flat sections (positions A, B and C) and three slides were placed next to them (positions D, E and F), such that the fold flat would replace the first three in the flight coating run. (See Figure 6)

In the flight coating run, three slides were placed in the D, E and F positions. These were compared to the D, E and F slides from the previous run, as measured by GIXR and normal incidence EUV reflectivity at NIST. Slight shifts in the bandpass positions of the flight coating run compared to the previous run were applied to the curves from the A, B and C slides from the previous run to determine the fold flat performance. These curves are shown in Figure 7a, as well as the measured performance of the coated G1 grating at m=0 order.

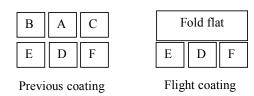
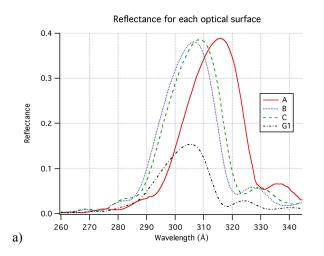


Figure 6. Schematic of witness slides with respect to the flight fold flat during testing and flight coating runs.

After adjusting for small shifts between deposition runs, the fold flat coating peaks in center of the A section at 315.8 Å, very close to our design goal of 315.3 Å. The B and C sections peak at 306.5 Å and 308.4 Å, compared to the goal of 306.3 Å. The absolute peak reflectivity of the A, B and C reflections is 39.0%, 38.1% and 38.6%, while the reflectivity at 303.6 Å is 22.2%, 36.5% and 34.5%, respectively. To gauge the performance of the optical system, the measured reflectivity of the G1 grating is multiplied by the measured reflectivity of fold flat witness samples, adjusted for minor shifts in the flight coating run. The result is shown in Figure 7b.



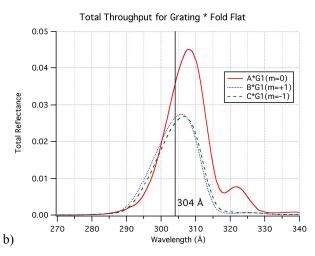


Figure 7. a) Individual reflectance of the G1 grating and fold flat. The grating curve, G1, is the reflectance at m = 0 order. b) The calculated total throughput of the optical system at the center of each channel. The relative efficiencies for the m = +1 and -1 orders are included, reducing the peak for these two channels.

Surface	Reflectivity	Suppression
	(%)	
G1	R(284) = 2.0	7.5x to 284 Å
	R(303.6) = 15.1	15.1x to 335
	R(335) = 1.0	Å
FF-A	R(284) = 1.6	12.9x to 284
	R(303.6) = 22.0	Å
	R(335) = 6.5	3.4x to 335 Å
FF-B	R(284) = 3.0	12.1x to 284
	R(303.6) = 36.5	Å
	R(335) = 2.5	14.5x to 335
		Å
FF-C	R(284) = 3.4	10.1x to 284
	R(303.6) = 34.5	Å
	R(335) = 3.7	9.5x to 335 Å
	G1 FF-A FF-B	(%) G1 R(284) = 2.0 R(303.6)= 15.1 R(335) = 1.0 FF-A R(284) = 1.6 R(303.6)= 22.0 R(335) = 6.5 FF-B R(284) = 3.0 R(303.6)= 36.5 R(335) = 2.5 FF-C R(284) = 3.4 R(303.6)= 34.5

Order	Reflectivity (%)	Suppression (x)
m = 0	R(284) = 0.0338	98.6x to 284 Å
	R(303.6) = 3.33	51.0x to 335 Å
	R(335) = 0.0653	
m=+1	R(284) = 0.0280	92.7x to 284 Å
	R(303.6)=2.59	223.4x to 335 Å
	R(335) = 0.0116	
m=-1	R(284) = 0.0317	76.4x to 284 Å
	R(303.6)=2.42	137.7x to 335 Å
	R(335) = 0.0176	
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Table 2. Suppression of Fe XV and XVI lines for a) individual reflections, and b) the two-reflection system. Values include the groove efficiencies for m = +1 and -1 order reflections for the grating.

From this last result, we can determine the ultimate performance of the coatings, which is the suppression of the Fe XV and XVI lines with respect to the 303.6 Å He II line, for individual reflections and the two-reflection system. Again, suppression is determined by taking the ratio between the reflectivity at 303.6 Å and that at 284 Å and 335 Å.

For individual reflections, where the bandpass peaks near 304 Å, suppression of nearby Fe lines is approximately a factor of 11. For telescope systems with two reflections, this means an improvement of a factor of nearly 100 can be achieved over more conventional broadband coatings. In terms of suppression, B₄C/Mg₂Si performs as well as any material combination reported to date, with the possible exception of Si/SiC.⁹ The very high peak reflectivity of 39% is also impressive, being a third higher than Si/B₄C. Suppression of nearby lines ranges from 51 times to 223 times for the combined system, shown in Table 2.

6. SUMMARY

The Multi-order Solar EUV Spectrograph (MOSES) is a slitless spectrometer designed to observe the sun at the 303.6 Å He II line. In order to simplify data analysis, the instrument requires a narrow band reflective coating to reject photons from nearby emission lines that will contaminate the images with undesired wavelengths. We have developed and demonstrated the performance of the B₄C/Mg₂Si multilayer combination for this purpose. The characteristics of nearly 40% reflectivity at the He II line, a narrow FWHM of 20 Angstroms, and good thermal and adhesion performance makes this material combination ripe for further development and consideration on long-term solar observing missions.

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